

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Assignee ..... Micron Technology, Inc.  
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## FEE DEFICIENCY

Although it is believed that no fees are due, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper to Deposit Account No. 23-0925.

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